

Title (en)

METHOD FOR PRODUCING ELECTRIC CONDUCTIVE STRUCTURES FOR USE IN HIGH-FREQUENCY TECHNOLOGY

Title (de)

VERFAHREN ZUR HERSTELLUNG VON HOCHFREQUENZTECHNISCH VERWENDBAREN ELEKTRISCHEN LEITUNGSSTRUKTUREN

Title (fr)

PROCEDE DE PRODUCTION DE STRUCTURES CONDUCTRICES ELECTRIQUES POUVANT ETRE UTILISEES DANS LE DOMAINE DE LA TECHNOLOGIE HAUTE FREQUENCE

Publication

EP 1527659 A1 20050504 (DE)

Application

EP 03792118 A 20030703

Priority

- DE 0302227 W 20030703
- DE 10236466 A 20020808

Abstract (en)

[origin: DE10236466A1] Production of high frequency electrical conducting structures on a conducting structure support comprises using a combination of laser structuring methods and etching methods with a resist which is thinly applied during the methods and has properties corresponding to chemical tin or an amorphous resist.

IPC 1-7

H05K 3/06; **H05K 1/02**

IPC 8 full level

H05K 1/02 (2006.01); **H05K 3/06** (2006.01); **H05K 1/00** (2006.01); **H05K 1/16** (2006.01); **H05K 3/00** (2006.01); **H05K 3/02** (2006.01)

CPC (source: EP KR)

H05K 1/02 (2013.01 - KR); **H05K 1/0242** (2013.01 - EP); **H05K 3/06** (2013.01 - KR); **H05K 3/061** (2013.01 - EP); **H05K 3/062** (2013.01 - EP); **H05K 1/0298** (2013.01 - EP); **H05K 1/165** (2013.01 - EP); **H05K 3/0035** (2013.01 - EP); **H05K 3/027** (2013.01 - EP); **H05K 2201/0179** (2013.01 - EP); **H05K 2203/107** (2013.01 - EP)

Citation (search report)

See references of WO 2004019665A1

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